



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroji AGA et al.

Group Art Unit: 2813

Application No.: 10/507,175

Examiner: C. RODGERS

Filed: September 10, 2004

Docket No.: 121026

For: METHOD OF PRODUCING SOI WAFER AND SOI WAFER

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the April 25, 2006 Office Action, please consider the following:

Amendments to the Drawings include an attached replacement sheets; and

Remarks.